

Title (en)

Method and apparatus for patterning substrates using gas streams.

Title (de)

Verfahren und Vorrichtung zum Bemustern von Materialien mittels Gasströmen.

Title (fr)

Procédé et appareil pour décorer des matières utilisant des jets de gaz.

Publication

**EP 0337777 A1 19891018 (EN)**

Application

**EP 89303652 A 19890412**

Priority

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- US 18040688 A 19880412

Abstract (en)

The dye may be applied uniformly, or in a pattern, preferably in the form of a spray. Liquid unfixed dye is applied to a substrate for the purpose of patterning the substrate. One or more streams of pressurized gas such as air are then directed onto the substrate for the purpose of displacing some of the unfixed dye where the streams impinge the substrate, thereby causing a visually distinctive area on the substrate where the relative dye concentration is reduced. Resulting products are also disclosed.

IPC 1-7

**D06B 11/00**

IPC 8 full level

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CPC (source: EP)

**D06B 11/0093** (2013.01); **D06C 23/00** (2013.01)

Citation (search report)

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